| Ref<br># | Hits | Search Query   | DBs   | Default<br>Operator | Plurals | Time Stamp       |
|----------|------|--|---|---------------------|---------|------------------|
| 1.1      | 0    | (optic\$ near waveguide\$) and<br>(amorphous near silicon) and<br>(crystalliz\$ near waveguide)    | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:55 |
| L2       | 578  | (optic\$ near waveguide\$) and<br>(amorphous near silicon)   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:55 |
| L3       | 5    | (optic\$ near waveguide\$) and<br>(amorphous near silicon) and<br>(laser near recrystallization\$) | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:57 |
| L4       | 1    | (laser near recrystallization\$) and (direct near patterning)                                      | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:58 |
| L5.      | 0    | (laser near recrystallization\$) and (alternating\$ near waveguide\$)                              | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:59 |
| L6       | 18   | (laser near recrystallization\$) and waveguide\$   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT | OR                  | OFF     | 2005/03/15 15:59 |